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# Micro-reflectance and transmittance spectroscopy: a versatile and powerful tool to characterize 2D materials

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## Abstract

Optical spectroscopy techniques such as differential reflectance and transmittance have proven to be very powerful techniques for studying 2D materials. However, a thorough description of the experimental setups needed to carry out these measurements is lacking in the literature. We describe a versatile optical microscope setup for carrying out differential reflectance and transmittance spectroscopy in 2D materials with a lateral resolution of  $\sim 1 \mu\text{m}$  in the visible and near-infrared part of the spectrum. We demonstrate the potential of the presented setup to determine the number of layers of 2D materials and characterize their fundamental optical properties, such as excitonic resonances. We illustrate its performance by studying mechanically exfoliated and chemical vapor-deposited transition metal dichalcogenide samples.

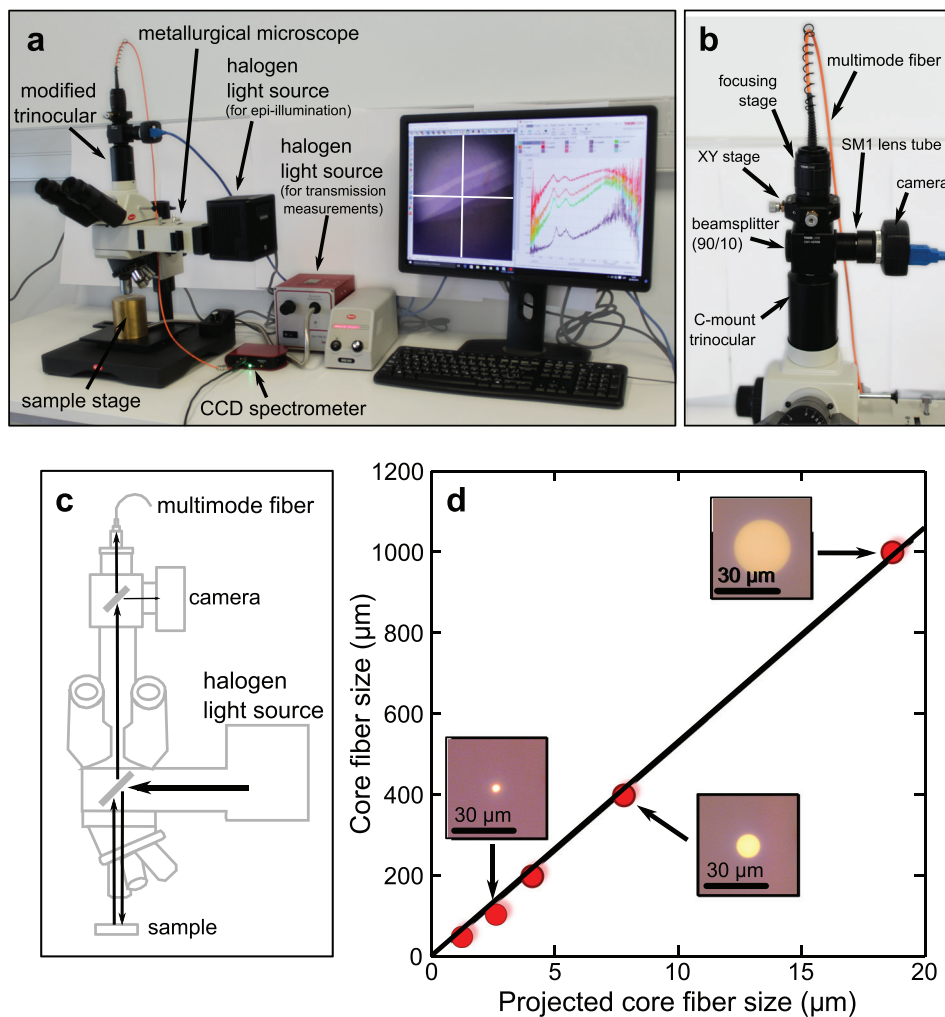
Keywords: 2D materials, optical spectroscopy, differential reflectance, transmittance, transition metal dichalcogenides

 Supplementary material for this article is available [online](#)

(Some figures may appear in colour only in the online journal)

The use of optical microscopy-based characterization techniques is closely bound up with the birth and growth of the field of 2D materials [1–5]. These techniques are widely used since they are fast and simple to implement and, very importantly, they are non-destructive. Quantitative studies of the optical contrast of flakes deposited on SiO<sub>2</sub>/Si substrates

were used first to provide a coarse estimate of the thickness of mechanically exfoliated flakes [3, 6–8]. Raman [2, 9] and photoluminescence spectroscopy [4, 5, 10–13] have proven to be very powerful techniques to determine the number of layers of 2D materials and study their intrinsic optical properties.



**Figure 1.** (a) Photograph of the experimental setup for performing micro-reflectance and transmittance spectroscopy on 2D materials, highlighting some of the key components. (b) Zoomed photograph of the modified trinocular. (c) Schematic diagram of the optical path of the setup operated in reflection mode. (d) Relationship between the size of the fiber core and its image on the sample surface due to the magnification of the optical system.

Differential reflectance has also been used recently to study the optical properties of 2D materials, especially transition metal dichalcogenides (TMDCs) [12, 14–17]. This technique provides a powerful tool to characterize 2D materials (even those that do not present strong excitonic features or Raman modes) in a broad range of the electromagnetic spectrum. Nevertheless, a thorough description of optical setups for characterizing 2D materials by differential reflectance is still lacking in the literature. This is the aim of this work: to accurately describe a versatile optical microscopy setup developed to carry out differential reflectance and transmittance measurements on 2D materials with  $\sim 1 \mu\text{m}$  spatial resolution in the wavelength range of 400 nm–900 nm (1.4 eV–3.1 eV). The entire system can be replicated easily with a relatively low investment (<9000 €). Moreover, existing optical microscopy setups could easily be upgraded to carry out these spectroscopic measurements.

## 1. Components of the experimental setup

Figure 1(a) shows a photograph of the micro-reflectance/transmittance setup that we developed to characterize 2D materials. The setup consists of a Motic BA310 metallurgical

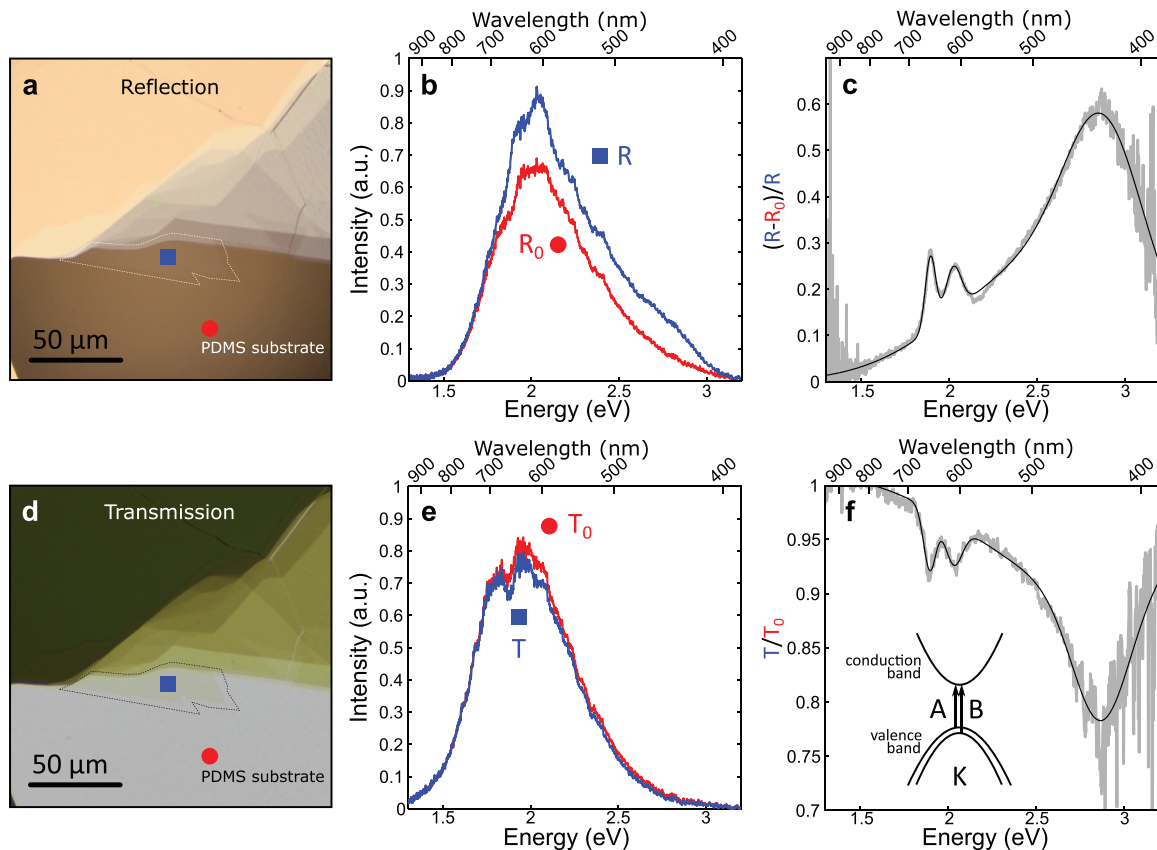
microscope, a modified trinocular port, a halogen light source with a liquid light guide and a fiber-coupled CCD spectrometer. Figure 1(b) shows a detailed photograph of the modified trinocular, indicating the different components employed for its assembly. A 90:10 beam splitter is connected to the C-mount trinocular in order to divide the trinocular light beam into two paths. In one of the paths (10% of the intensity) a CMOS camera is placed at the image plane of the optical system to acquire images of the studied sample. In the other path (90% of the intensity) we place a multimode fiber, also at the image plane, projecting an image of the studied sample onto the surface of the fiber end. Table 1 summarizes the complete list of components necessary to assemble the experimental setup, including their part number, distributor and purchase price.

## 2. Setting up the microscope

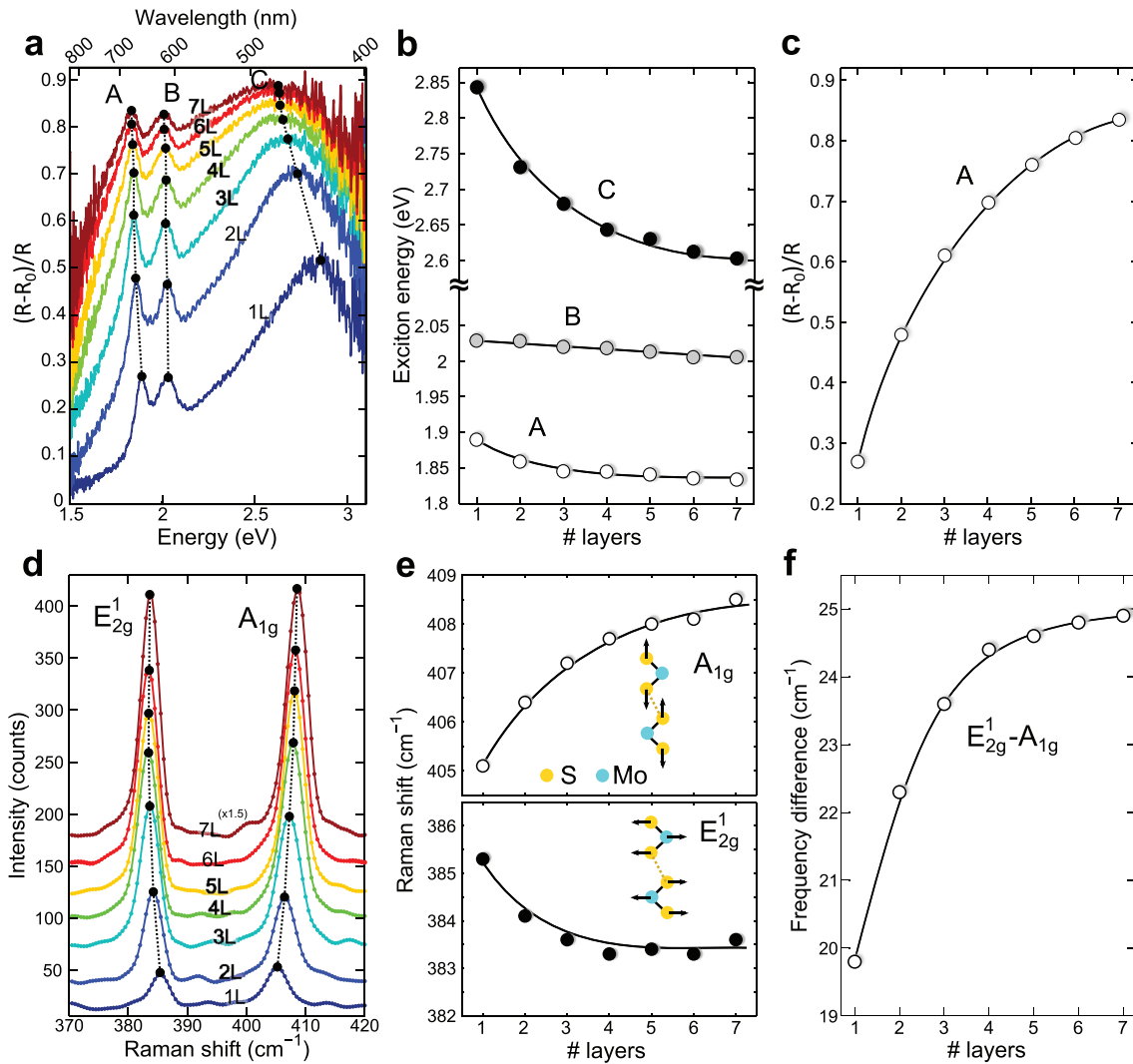
The size of the fiber core acts as a confocal pinhole, and thus the fiber only collects the light coming from a small region of the sample. In order to determine the area and position of this region one can connect the free end of the multimode fiber to

**Table 1.** List of the components employed to assemble the experimental setup.

Part number	Description	Distributor	Price (€)
BA310Met-H Trinocular	Metallurgical microscope (with epi-illumination)	Motic	3620.00
CCS200/M	CCD spectrometer	Thorlabs	2475.00
OSL2	Halogen lamp with fiber bundle	Thorlabs	807.30
SM1SMA	Adaptor to connect the multimode fiber to the halogen lamp	Thorlabs	25.22
Adaptor BA series	C-mount threaded trinocular	Motic	127.00
SM1A10	Adaptor to connect the beam splitter mount to the C-mount trinocular	Thorlabs	16.88
CCM1-4ER/M	Mount for beam splitter cube	Thorlabs	115.20
BS025	90:10 beam splitter cube	Thorlabs	186.30
SM1A10	Adaptor to connect the beam splitter mount to the XY stage	Thorlabs	16.88
CXY1	XY stage	Thorlabs	152.15
SM1NR05	Focusing stage	Thorlabs	162.00
SM05SMA	Adaptor to connect the multimode fiber to the focusing stage	Thorlabs	24.57
M96L01	105 $\mu\text{m}$ core multimode fiber	Thorlabs	95.53
SM1V10	SM1 lens tube to connect to the beam splitter mount	Thorlabs	29.34
SM1A39	Adaptor to connect the SM1 lens tube to the CMOS camera	Thorlabs	18.00
#89-734	CMOS camera	Edmund optics	563.50
—	Homemade brass sample holder with a hole for the fiber bundle	Workshop	150.00
		Total	8584.87



**Figure 2.** (a) Optical reflection image of an MoS<sub>2</sub> flake transferred onto a PDMS substrate (epi-illumination). The single layer area is highlighted with a dashed line. (b) Reflection spectra acquired at the positions marked with the blue square and red circle in (a). (c) Calculated differential reflectance of the single layer MoS<sub>2</sub> from the spectra displayed in (b). The thin black line is a multi-Gaussian fit used to extract the peak position and full width at half maximum values of the different excitons. (d) Transmission mode optical image of the flake shown in (a). (e) Transmission spectra acquired on the flake (blue square) and substrate (red circle) are employed to calculate the transmittance spectrum of the single layer flake (f). The inset in (f) shows a simplified schematic of the band diagram around the K point that illustrates the origin of the two excitonic resonances at 1.90 eV and 2.05 eV.



**Figure 3.** (a) Differential reflectance spectra acquired for MoS<sub>2</sub> flakes with different numbers of layers. The peak positions of the different excitons are highlighted by filled circles. (b) Thickness dependence of the exciton energy. (c) Amplitude of the A exciton peak as a function of the number of layers. (d) Raman spectra acquired for MoS<sub>2</sub> flakes with different numbers of layers. The peak positions of the two most prominent Raman modes are highlighted by filled circles. (e) Thickness dependence of the Raman shift of the A<sub>1g</sub> and E<sub>2g</sub><sup>1</sup> modes. The insets in (d) show an artistic representation of the vibrational modes. (f) Frequency difference between the Raman modes as a function of the number of layers.

a white light source (e.g. the halogen light source), yielding an image of the fiber end facet in the sample plane. The image of the fiber core at the end facet is projected according to the magnification of the microscope lenses and objective assembly. Figure 1(d) shows the relationship between the core diameter of the different multimode fibers and their apparent size in the sample plane. An XY stage allows one to align the image of the end facet with the digital crosshair of the camera that marks the center of the sample image. With a reversed beam path (see figure 1(c)), this corresponds to the light collection spot and it is possible to determine where the spectra are collected once the light source is disconnected from the fiber end. A focusing stage in the trinocular also allows one to accurately place the fiber core end right in the image plane by moving the focusing stage until the projected fiber core image and the surface of the studied sample are both perfectly in focus. Once the size for light collection has been determined, centered in the crosshair and focused, the fiber is disconnected

from the white light source and the free end of the fiber is connected to the fiber-coupled CCD spectrometer.

### 3. Acquisition of micro-reflectance or transmittance spectra

To acquire a micro-reflectance spectrum the microscope is operated in epi-illumination mode. The white light of the microscope halogen lamp is reflected onto the sample, collected through a long working distance (infinity corrected) 50× microscope objective (NA 0.55) and directed to the modified trinocular. In epi-illumination operation, closing the field aperture of the microscope (to ~60 μm in diameter) reduces the stray light collected by the finite numerical aperture of the objective lens. Transmittance spectra can also be acquired by turning off the microscope lamp and placing the sample onto a sample holder connected to the halogen light source by a fiber bundle (NA 0.57). The sample holder has a see-through



hole where the fiber bundle can be slid in. The sample is directly placed onto the end facet of the fiber bundle without using other lenses (see the supplementary material, available at [stacks.iop.org/JPhysD/50/074002/mmedia](http://stacks.iop.org/JPhysD/50/074002/mmedia)).

#### 4. Experimental results for monolayer and few-layer TMDCs

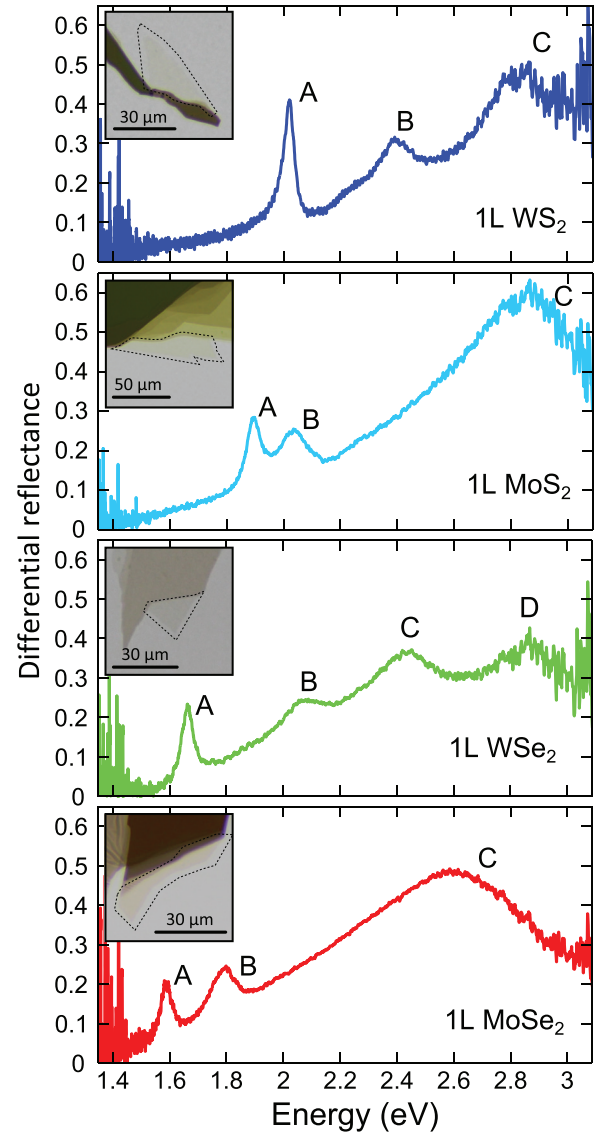
Figure 2(a) shows a reflection mode optical image of a MoS<sub>2</sub> flake deposited onto a PDMS substrate (gel film from Gel-Pak®) by mechanical exfoliation of bulk MoS<sub>2</sub> (Moly Hill mine, Quebec, QC, Canada) with Nitto tape (Nitto Denko Co., SPV224 clear). The single-layer region of the flake is highlighted with a dashed line to facilitate its identification. Figure 2(b) shows the spectra acquired at the positions marked in the optical image of figure 2(a) with a blue square (flake,  $R$ ) and a red circle (substrate,  $R_0$ ). The differential reflectance spectrum is then calculated as  $(R - R_0)/R$  (see figure 2(c)) and it is related to the absorption coefficient of the material  $\alpha(\lambda)$  as [14, 18]

$$\frac{R - R_0}{R} = \frac{4n}{n_0^2 - 1} \alpha(\lambda),$$

where  $n$  is the refractive index of the flake under study and  $n_0$  is the refractive index of the substrate. Figure 2(d) shows a transmission mode optical image of the flake shown in figure 2(a). Figure 2(e) shows the transmission spectra acquired at the positions highlighted with a blue square (flake,  $T$ ) and red circle (substrate,  $T_0$ ) in figure 2(d). The flake transmittance can be determined directly by dividing  $T/T_0$  (see figure 2(f)).

Both the differential reflectance and transmittance spectra have two prominent narrow peaks/dips occurring at photon energies  $\sim 1.90$  eV and  $\sim 2.05$  eV, which correspond to the optical absorption due to the direct transitions at the K point of the Brillouin zone and are associated with the generation of the A and B excitons, respectively. This observation is in agreement with previous photoluminescence studies [4, 5, 19]. The inset in figure 2(f) shows a simplified band diagram at the K point of the Brillouin zone, where the origin of the A and B excitonic resonances is illustrated. The valence band is split because the strong spin-orbit interaction due to the Mo atoms gives rise to two direct band gap transitions at the K point. The spectra also show a broad feature around 2.85 eV. This feature is not typically observed in photoluminescence experiments, which mostly use an excitation wavelength of  $\sim 2.3$  eV. Recent hyperspectral, reflectance, ellipsometry and photocurrent spectroscopy experiments, however, present this feature (referred to as the C exciton peak). It originates from singularities in the joint density of states between the first valence and conduction bands near the  $\Gamma$  point of the valence band, which lead to multiple optical transitions that are nearly degenerate in energy [14, 15, 20–24].

Micro-reflectance and transmittance are interesting techniques for determining the number of layers of 2D materials. Figure 3(a) shows, as an example, the differential reflectance spectra acquired for MoS<sub>2</sub> flakes with a thickness ranging from one to seven layers. One can determine the number of

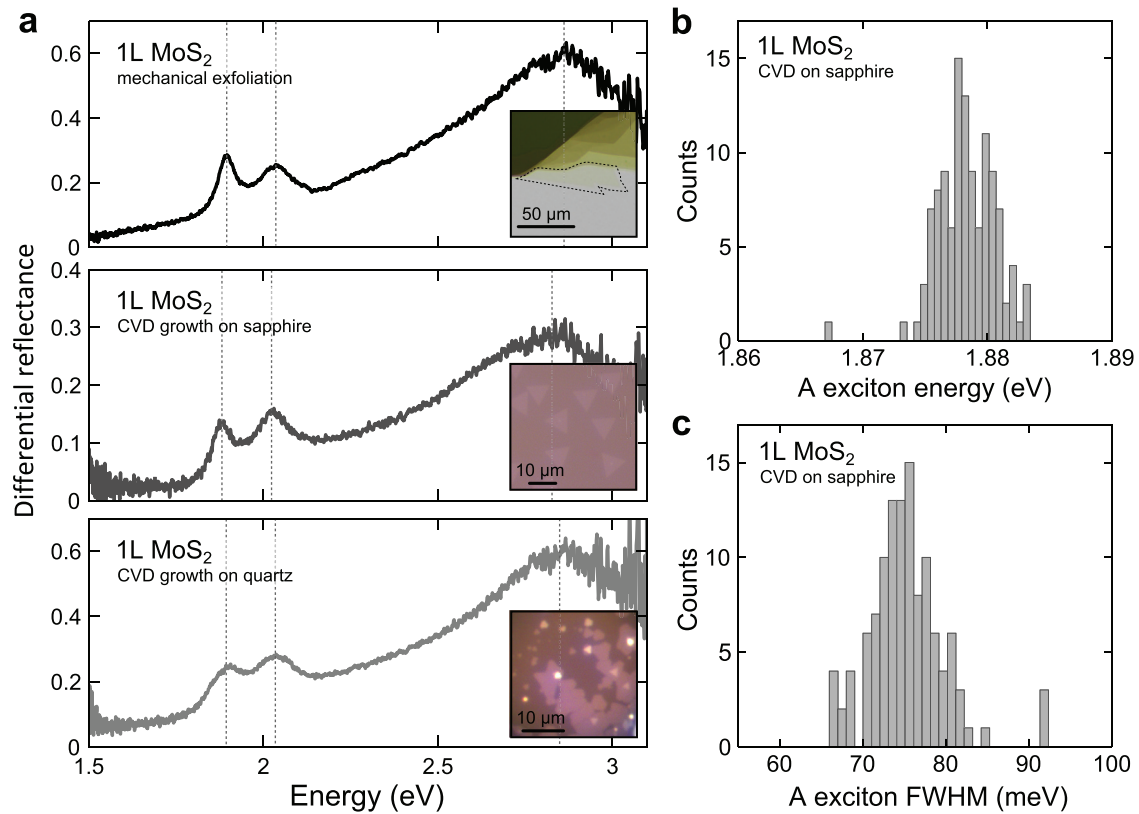


**Figure 4.** Differential reflectance spectra acquired for single-layer flakes of different transition metal dichalcogenides: WS<sub>2</sub>, MoS<sub>2</sub>, WSe<sub>2</sub> and MoSe<sub>2</sub> (from top to bottom). The exciton resonances are highlighted according to the notation employed in the literature [15, 27]. (Insets) Transmission mode optical images of the studied single-layer flakes (highlighted with a dashed line).

**Table 2.** Summary of the A and B exciton energies extracted from the differential reflectance measurements shown in figure 4.

Material	A exciton (eV)	B exciton (eV)
1L WS <sub>2</sub>	2.02	2.39
1L MoS <sub>2</sub>	1.90	2.04
1L WSe <sub>2</sub>	1.66	2.06
1L MoSe <sub>2</sub>	1.59	1.80

layers from the energy of the A exciton, which blue-shifts upon reduction of the number of layers (see figure 3(b)) [25]. The B exciton, on the other hand, shows a weaker thickness dependence [25]. These results are in good agreement with previous photoluminescence measurements [5]. Interestingly, the C exciton peak also shifts with the number of layers and its dependence is even stronger than that of the A exciton; one



**Figure 5.** Differential reflectance spectra acquired on single-layer MoS<sub>2</sub> samples prepared by mechanical exfoliation on PDMS (top panel in (a)), CVD growth on sapphire (middle panel in (a)) and CVD growth on quartz (bottom panel in (a)). The insets in (a) show optical images of the studied samples. (b) and (c) The statistical analysis of the energy and full-width at half maximum of the A exciton peak measured over 116 MoS<sub>2</sub> crystallites on the CVD sample grown on sapphire, showing the remarkable uniformity of the CVD grown material.

can thus use the position of the C exciton peak to independently determine the number of layers of MoS<sub>2</sub> [14]. Note that photoluminescence measurements are typically limited to the study of the A and B excitons, as the excitation laser employed is typically in the 2.0–2.3 eV range [4, 16]. Figure 3(b) summarizes the thickness dependence of the A, B and C exciton resonances. A more comprehensive study of the thickness dependent excitonic features in W- and Mo-based TMDCs will be published elsewhere.

The micro-reflectance measurements of MoS<sub>2</sub> flakes with different thicknesses (figures 3(a)–(c)) are compared with results obtained with Raman spectroscopy. Raman spectroscopy is a well-established technique to determine the number of layers of MoS<sub>2</sub>, as the frequency difference between the two most prominent Raman modes (the  $A_{1g}$  and the  $E_{2g}^1$  peaks) increases monotonically with the number of layers [9, 26]. Figure 3(d) shows the Raman spectra acquired on the MoS<sub>2</sub> flakes on PDMS, with different numbers of layers. The thickness dependence of the two modes is displayed in figure 3(e). Figure 3(f) depicts the frequency difference between these two Raman modes. A direct comparison between figure 3(f) and figures 3(b), (c) indicates that micro-reflectance measurements are very effective for determining the number of layers, especially for multilayer flakes (thicker than four layers) where the frequency difference between the Raman modes starts to saturate.

It is important to note that micro-reflectance (or transmittance) measurements are very powerful for investigating indirect band gap semiconductors that typically require long exposure times in order to be studied by photoluminescence. In fact, the quantum yield of MoS<sub>2</sub> strongly decreases by more than a factor of 1000 from the single layer case (direct band gap) to the multilayer case (indirect band gap) [5]. Moreover, these techniques can be used to study the optical properties of conducting and insulating materials without strong excitonic features, which constitutes another important advantage with respect to photoluminescence.

In order to illustrate the flexibility and versatility of this technique for identifying and studying other 2D materials we acquired differential reflectance spectra for single-layer flakes of other TMDCs. Figure 4 shows a comparison between the differential reflectance spectra of single-layer WS<sub>2</sub>, MoS<sub>2</sub>, WSe<sub>2</sub> and MoSe<sub>2</sub>. The excitonic resonances are labelled according to the standard notation employed in the literature. One can easily identify the material from the position of the A and B exciton peaks (see table 2), which are in very good agreement with the reported values from photoluminescence experiments [4, 17, 26, 27]. The origin of these A and B excitonic resonance peaks in WS<sub>2</sub>, WSe<sub>2</sub> and MoSe<sub>2</sub> is very similar to that in MoS<sub>2</sub>, i.e. the direct band gap transitions at the K point of the Brillouin zone (as sketched in the inset of figure 2(f)). Therefore, one can estimate the magnitude of the

spin-orbit interaction in these materials from the energy difference between the A and B exciton. For W-based TMDCs this value is larger due to the higher atomic number of W with respect to Mo. Similarly, for the same transition metal, the Se-based TMDCs show greater spin-orbit interaction than the S-based ones. The C peak observed in  $WS_2$  and  $MoSe_2$  is believed to have the same origin as the one observed in  $MoS_2$  [14, 15, 20–24, 28]. In the case of  $WSe_2$  several transitions along the  $\overline{KT}$  direction contribute to the C exciton. The D exciton transitions stem from the same bands as in the case of the B exciton, but occur along the  $\overline{KM}$  direction [17, 27].

Finally, we demonstrate the suitability of differential reflectance for characterizing 2D materials prepared using large area growth methods such as chemical vapor deposition (CVD). Figure 5(a) compares the differential reflectance spectra acquired for monolayers of  $MoS_2$  prepared by mechanical exfoliation and by CVD growth. Two different sets of CVD-prepared samples are characterized (see the supplementary material, available at [stacks.iop.org/JPhysD/50/074002/mmedia](http://stacks.iop.org/JPhysD/50/074002/mmedia), for details on the growth methods). One has been grown on a highly polished sapphire substrate and results in characteristic single-crystal domains in the shape of well-defined equilateral triangles [29]. The other CVD sample has been grown directly on a quartz substrate. The energy of the excitonic peaks of the CVD samples is consistent with that measured on mechanically exfoliated single-layer  $MoS_2$ , although it is slightly red-shifted. This red-shift in CVD-grown samples is typically attributed to strain induced during the thermal cycling during growth [30]. Differential reflectance spectroscopy is therefore also a powerful tool for studying CVD-grown samples. Moreover, the fast measurement time (approximately 1 second per spectrum) allows one to analyze the quality of a CVD-grown sample statistically by acquiring spectra over a large number of sample positions. Figures 5(b) and (c) show histograms of the energy and full width at half maximum of the A exciton peak measured on 116 different  $MoS_2$  triangular-shaped crystallites grown on the sapphire substrate, demonstrating the high uniformity of the CVD sample.

## 5. Conclusions

In summary, we have presented a simple and versatile optical microscope setup for carrying out micro-reflectance and transmittance spectroscopy with a lateral resolution of  $\sim 1 \mu m$  in the spectral range 400 nm–900 nm. The setup can be used to unambiguously identify different 2D materials and determine their thicknesses, and also to characterize their fundamental optical properties. We believe that the presented setup can be replicated easily by other groups, as it is mainly based on standard commercially available optical components that can be purchased for a price of less than 9000 €. Moreover, existing optical microscope setups can be upgraded easily by purchasing only some of the components.

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